

MOSFET

Metal Oxide Semiconductor Field Effect Transistor

Bare Die

OptiMOS™2 Power MOS Transistor Chip IPC26N10NR

Data Sheet

Rev. 2.5 Final





IPC26N10NR

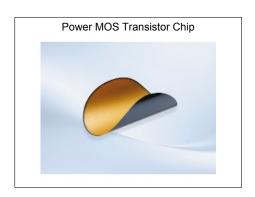
1 **Description**

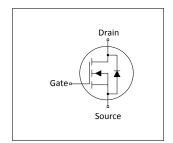
- N-channel enhancement mode
- For dynamic characterization refer to the datasheet of IPP05CN10N G1)
- AQL 0.65 for visual inspection according to failure catalogue
- Electrostatic Discharge Sensitive Device according to MIL-STD 883C

- Die bond: soldered or glued
 Backside metallization: NiV system
 Frontside metallization: AlSi system
- Passivation: nitride (only on edge structure)



Table 1 Rey 1 ci formance i arameters					
Parameter	Value	Unit			
V _{(BR)DSS}	100	V			
R _{DS(on)}	5.4 ²⁾	mΩ			
Die size	6.0 x 4.36	mm ²			
Thickness	250	μm			











Type / Ordering Code	Package	Marking	Related Links
IPC26N10NR	Chip	not defined	-

²⁾ packaged in a P-TO220-3-1 (see ref. product)

¹⁾ IPP05CN10N G dynamic characterization does not include the internal added R_G





2 Electrical Characteristics on Wafer Level at T_j = 25°C, unless otherwise specified

Table 2

Danamatan.	Symbol		Values		110014	Nata (Tant Oan dition
Parameter		Min.	Тур.	Max.	Unit	Note / Test Condition
Drain-source breakdown voltage	V _{(BR)DSS}	100	-	-	V	V _{GS} =0 V ,I _D =1 mA
Gate threshold voltage	V _{GS(th)}	2	-	4	V	V _{DS} =V _{GS} , I _D =250 μA
Zero gate voltage drain current	I _{DSS}	-	0.1	1	μA	V _{GS} =0 V ,V _{DS} =100 V
Gate-source leakage current	I _{GSS}	-	1	100	nA	V _{GS} =20 V ,V _{DS} =0 V
Drain-source on- resistance	R _{DS(on)}	-	3.2 ¹⁾	100 ²⁾	mΩ	V _{GS} =10 V ,I _D =2.0 A
Reverse diode forward on-voltage	V _{SD}	-	1.0	1.2	V	V _{GS} =0 V ,I _F =1A
Internal gate resistance	R _G	-	1.8	-	Ω	-
Additional gate resistor	R _{Gadd}	-	16	-	Ω	-
Avalanche energy, single pulse	E AS	-	125 ³⁾	-	mJ	I _D =50 A, R _{GS} =25 Ω

 $^{^{1)}}$ typical bare die $R_{\rm DS(on)};~V_{\rm GS}$ =10 V $^{2)}$ limited by wafer test-equipment $^{3)}$ Wafer tested. For general avalanche capability refer to the datasheet of IPP05CN10N G



3 Package Outlines

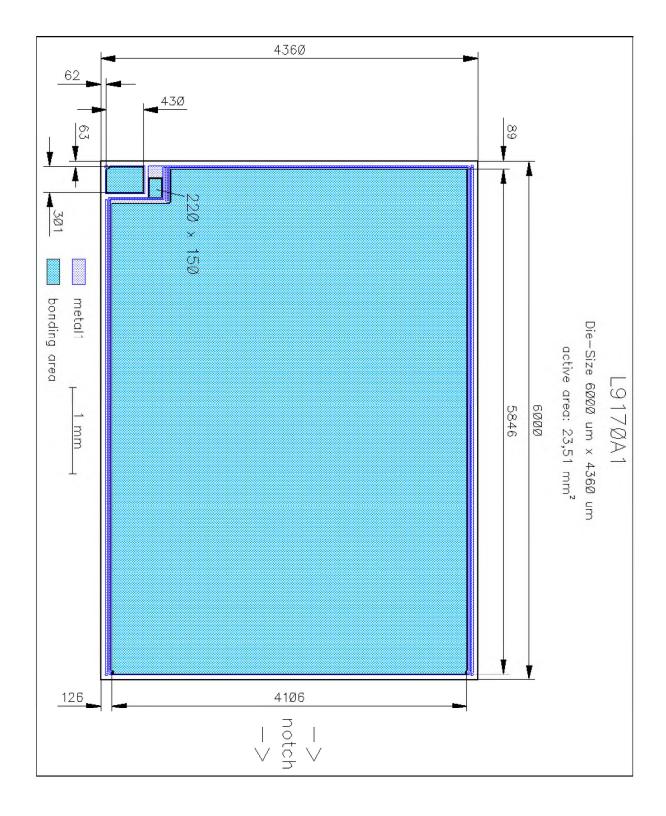


Figure 1 Outline Chip, dimensions in µm



OptiMOS™2 Power MOS Transistor Chip

IPC26N10NR

Revision History

IPC26N10NR

Revision: 2014-10-03, Rev. 2.5

Previous Revision

Trevious Nevision				
Revision	Date	Subjects (major changes since last revision)		
2.5	2014-10-03	Release Final Version		

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